

Electronic Acknowledgement Receipt

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International Application Number:	
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Title of Invention:	Apparatus for controlling gas flow in a semiconductor substrate processing chamber
First Named Inventor/Applicant Name:	Kallol Bera
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes) /Message Digest	Multi Part /.zip	Pages (if appl.)
1	Information Disclosure Statement (IDS) Filed	008549_SIDS_EF.pdf	722992	no	4
			abef5d0ddab959a0a33b0c4e4105d3a7d56c3097103		

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2	NPL Documents	008549_OfficeAction_EF.pdf	640949	no	9
			146889268b13e3589e457aba3f350207a90305a		

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3	Fee Worksheet (PTO-06)	fee-info.pdf	8211	no	2
			1c0d1a113556537c36277f7baf84732057a9f41		

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